

PROCEEDINGS OF SPIE

Optical Precision Manufacturing, Testing, and Applications

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Editors

22–24 May 2018
Beijing, China

Organized by

Chinese Society for Optical Engineering (CSOE) (China)
Photoelectronic Technology Committee, Chinese Society of Astronautics (China)
Photoelectronic Industrialization Committee, CHIA (China)
Department of Cooperation and Coordination for Industry, Academe and Research, CHIA (China)
Science and Technology on Low-light-level Night Vision Laboratory (China)

Sponsored by

Division of Information and Electronic Engineering of Chinese Academy of Engineering (China)
Chinese Society for Optical Engineering (CSOE) (China)

Published by

SPIE

Volume 10847

Proceedings of SPIE 0277-786X, V. 10847

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

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Author(s), "Title of Paper," in *Optical Precision Manufacturing, Testing, and Applications*, edited by John W. McBride, JiuBin Tan, Sen Han, Xuejun Zhang, Proceedings of SPIE Vol. 10847 (SPIE, Bellingham, WA, 2018) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510623361

ISBN: 9781510623378 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) Fax +1 360 647 1445

SPIE.org

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Printed in the United States of America

Publication of record for individual papers is online in the SPIE Digital Library.

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